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Karen Vertz	(Depositor's name)
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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/885,744	06/20/2001	Hiroaki Niimi	TI-32705	5587

TITLE OF INVENTION: METHOD FOR ANNEALING ULTRA-THIN, HIGH QUALITY GATE OXIDE LAYERS USING OXIDIZER/HYDROGEN MIXTURES

APPLN. TYPE	SMALL ENTITY	ISSUE FEE	PUBLICATION FEE	TOTAL FEE(S) DUE	DATE DUE
nonprovisional	NO	\$1330	\$300	\$1630	08/17/2004

EXAMINER	ART UNIT	CLASS-SUBCLASS
NGUYEN, KHIEM D	2823	438-287000

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Applicant Hiroaki Niimi, et al.

Docket Number: TI-32705

Serial No.: 09/885,744

Art Unit: 2823

Filed: 06/20/01

Examiner: Khiem D. Nguyen

For: Method for Annealing Ultra-Thin, High Quality Gate Oxide
Layers Using Oxidizer/Hydrogen Mixtures

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NAME OF INVENTOR(S): Hiroaki Niimi, et al.	
TITLE OF INVENTION: Method for Annealing Ultra-Thin, High Quality Gate Oxide Layers Using Oxidizer/Hydrogen Mixtures	
TI FILE NO.: TI-32705	DEPOSIT ACCT. NO.: 20-0668
FAXED: 5-21-04 DUE: 8-17-04 ATTY/SECY: GCH/kjv	
RECEIPT DATE & SERIAL NO.: Serial No.: 09/885,744 Filing Date: 06/20/01	

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